Applicant: Shunpei Yamazaki, et al. Attorney's Docket No.: 07977-279001 / US5023/5025

Serial No. : 09/892,225 Filed : June 25, 2001

Page : 2 of 21

## Amendments to the Specification:

Please replace the paragraph beginning at page 28, line 24 to page 29, line 1 with the following amended paragraph:

A metal element which promotes the crystallization of silicon introduced into the first and second amorphous semiconductor films is rapidly diffused in the amorphous semiconductor films during the <a href="https://hydrogenation.org/hydrogenation">hydrogenation</a> dehydrogenation treatment.